What is claimed is:

- 1 1. A system adapted to analyze a semiconductor die, the system comprising:
- 2 a light source;
- a semiconductor analysis arrangement adapted to hold a semiconductor die and
- 4 to use light from the light source to perturb the die for analyzing the die; and
- a fiber optic cable coupled between the light source and the analysis
- 6 arrangement and adapted to direct light from the light source to the die in the analysis
- 7 arrangement.
- 1 2. The system of claim 1, further comprising a light direction arrangement adapted
- 2 to direct light from the fiber optic cable to a selected portion of the die.
- 1 3. The system of claim 1, wherein the light source includes a laser source.
- 1 4. The system of claim 1, wherein the semiconductor analysis arrangement
- 2 includes a test chamber having a fixture adapted to hold the semiconductor die.
- 1 5. The system of claim 4, wherein the analysis arrangement is adapted to evacuate
- 2 the test chamber.
- 1 6. The system of claim 5, wherein the light source is located outside of the test
- 2 chamber, and wherein the fiber optic cable extends from the light source and into the
- 3 test chamber.

- 1 7. The system of claim 1, further comprising a controller adapted to control the
- 2 semiconductor analysis arrangement.
- 1 8. The system of claim 7, wherein the controller includes a computer.
- 1 9. The system of claim 1, wherein the fiber optic cable includes a primary fiber
- 2 optic waveguide surrounded by a protective fiber optic waveguide.
- 1 10. The system of claim 1, wherein the fiber optic cable extends into the analysis
- 2 arrangement and is adapted to direct light to a semiconductor die held in the analysis
- 3 arrangement.
- 1 11. The system of claim 1, wherein the analysis arrangement includes a detection
- 2 arrangement adapted to detect a response from the die to the light.
- 1 12. The system of claim 11, wherein the detection arrangement is adapted to detect a
- 2 failure condition of the die.
- 1 13. The system of claim 1, further comprising at least one perturbation device in
- 2 addition to the light source, the perturbation device adapted to perturb the die.
- 1 14. A system adapted to analyze a semiconductor die, the system comprising:

2 me	ans for gene	rating light;
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- means for holding a semiconductor die and using the generated light to perturb
- 4 the die for analyzing the die; and
- a fiber optic cable coupled between the means for generating light and the
- 6 means for holding a semiconductor die and adapted to direct light from the means for
- 7 generating light to the means for holding a semiconductor die.
- 1 15. A method for analyzing a semiconductor die, the method comprising:
- 2 generating light;
- directing the generated light to a die analysis arrangement via a fiber optic cable;
- 4 and
- 5 holding a semiconductor die and using the generated light to perturb the die for
- 6 analyzing the die.
- 1 16. The method of claim 15, wherein generating light includes generating laser
- 2 light.
- 1 17. The method of claim 15, wherein using the generated light for analyzing the die
- 2 includes directing the generated light to a selected portion of the die and stimulating the
- 3 selected portion, further comprising detecting a response from the die to the stimulation
- 4 and using the response to detect a characteristic of the die.

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- 1 18. The method of claim 17, wherein using the response to detect a characteristic of
- 2 the die includes detecting a cause of a failure of the die.
- 1 19. The method of claim 15, further comprising placing the die in a vacuum
- 2 chamber and drawing a vacuum on the chamber, wherein holding the die includes
- 3 holding the die in the chamber, wherein generating light includes generating light
- 4 outside of the vacuum chamber and wherein directing the generated light to a die
- 5 analysis arrangement via a fiber optic cable includes directing the generated light via a
- 6 fiber optic cable extending into the vacuum chamber.